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INFORMATION DISCLOSURE
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Complete if Known

Application Number	10/662,979
Filing Date	September 15, 2003
First Named Inventor	Charles W. Extrand
Art Unit	2262
Examiner Name	Robert W. Hodge
Attorney Docket Number	2267.841US03

Sheet 1 of 7

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EXAMINER INITIAL ¹	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number-Kind Code ² (if known)		
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RWH		US-6,660,363 B1	12/09/2003	Wilhelm Barthlott
RWH		US-6,623,882 B2	09/23/2003	Jefferson Yang
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Sheet	2	of	7	Attorney Docket Number	2267.841 US03
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EXAMINER INITIAL*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)			
X		WO 02/084340 A1	10/24/2002	Ming-Hsien Wu et al.	
		WO 01/92179 A1	12/06/2001	Karsten Reihs et al.	
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EXAMINER SIGNATURE		Ralf Hader		DATE CONSIDERED	2-17-05
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.</p> <p>This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.</p>					

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NON PATENT LITERATURE DOCUMENTS					
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EXAMINER SIGNATURE	<i>Paul Hader</i>			DATE CONSIDERED	2-17-05
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